

Application No.	Applicant(s)	
09/592,009	LEE ET AL.	
Examiner	Art Unit	
Kim Huynh	2182	

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SEARCHED						
Class	Subclass	Date	Examiner			
710	5,36,48, 29,266	2/3/05	cq			
712	228	•	4			
Und	- scol	8/15/B	Q			
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INTERFERENCE SEARCHED				
Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
EAST, PGPUG, USPTO, JPO, EPO, DERWENT, NPL, PLUS	2/3/08	Of	
Inventor Sears	2/7/25	Og	
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